
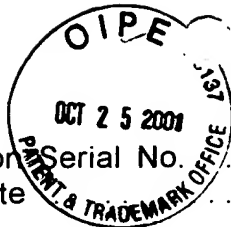


REMARKS

Claims 16-29 are cancelled, leaving claims 1-15 pending in the application. In response to the Examiner's request for election of a species, Applicant elects the species of Group I (claims 1-15). Applicant requests substantive examination of claims 1-15.

Dated: 10/25/01

Respectfully submitted,
By: 
David G. Latwesen, Ph.D.
Reg. No. 38,533



Application Serial No. 09/754,926
Filing Date 1/4/01
Inventor Ahn et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner E. Keilin
Attorney's Docket No. MI22-1533
Title: Methods of Forming Silicon-Doped Aluminum Oxide, and Methods of
Forming Transistors and Memory Devices

VERSION WITH MARKINGS TO SHOW CHANGES MADE ACCOMPANYING
RESPONSE TO SEPTEMBER 28, 2001 OFFICE ACTION

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C 2800 MAIL ROOM

In the Claims

The claims have been amended as follows. Underlines indicate insertions
and ~~strikeouts~~ indicate deletions.

Cancel claims 16-29.

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